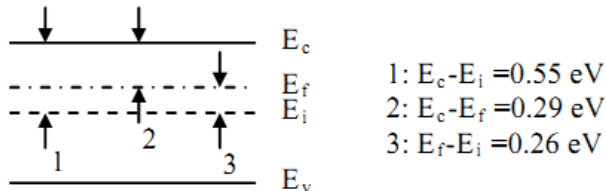


Name:

- 1- In a silicon sample at  $T = 300\text{ K}$ , the Fermi level is located at  $0.26\text{ eV}$  ( $10\text{ kT}$ ) above the intrinsic Fermi level. What are the hole and electron concentrations?  $N_c = 2.8 \times 10^{19}\text{ cm}^{-3}$ ,  $k = 1.38 \times 10^{-23}\text{ J.K}^{-1}$ ,  $q = 1.6 \times 10^{-19}\text{ C}$ ,  $n_i = 10^{10}\text{ cm}^{-3}$ .

**Solution:**

Since the Fermi level is located  $0.26\text{ eV}$  above  $E_i$  and closer to  $E_c$ , the sample is n-type. If we assume that  $E_i$  is located at the mid-bandgap ( $\sim 0.55\text{ eV}$ ), then  $E_c - E_f = 0.29\text{ eV}$ .



$$n = N_c e^{-(E_c - E_f)/kT} \quad \longrightarrow \quad n = \frac{N_c}{e^{(E_c - E_f)/kT}}$$

$$n = \frac{2.8 \times 10^{19}\text{ cm}^{-3}}{2.718^{(0.29\text{ eV} * 1.6 \times 10^{-19}\text{ C}) / (1.38 \times 10^{-23}\text{ J.K}^{-1} * 300\text{ K})}}$$

$$n = \frac{2.8 \times 10^{19}\text{ cm}^{-3}}{2.718^{(4.64 \times 10^{-20}) / (4.14 \times 10^{-21})}}$$

$$n = \frac{2.8 \times 10^{19}\text{ cm}^{-3}}{2.718^{11.2}}$$

$$n = \frac{2.8 \times 10^{19}\text{ cm}^{-3}}{7.3 \times 10^4} = 0.38 \times 10^{15}\text{ cm}^{-3} = 3.8 \times 10^{14}\text{ cm}^{-3}$$

$$p = \frac{n_i^2}{n}$$

$$p = \frac{n_i^2}{n} = \frac{(10^{10})^2}{3.8 \times 10^{14}\text{ cm}^{-3}} = \frac{10^{20}}{3.8 \times 10^{14}} = 2.63 \times 10^5\text{ cm}^{-3}$$

- 2- Boron atoms are added to a Si film resulting in an impurity density of  $4 \times 10^{16}\text{ cm}^{-3}$ .

- What is the conductivity type (N-type or P-type) of this film?
- Why does the mobile carrier concentration increase at high temperatures?

**Solution:**

- B is a group III element. When added to Si (which belongs to Group IV), it acts as an acceptor producing a large number of holes. Hence, this becomes a P-type Si film.
- At high temperatures, there is enough thermal energy to free more electrons from silicon-silicon bonds, and consequently, the number of intrinsic carriers increases.